

<b>Notice of References Cited</b>	Application/Control No. 10/779,736	Applicant(s)/Patent Under Reexamination KUO, CHEN LUNG	
	Examiner W. Patty Chen	Art Unit 2871	Page 1 of 1

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*	B	US-6,211,937	04-2001	Miyachi et al.	349/156
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	K	US-			
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**NON-PATENT DOCUMENTS**

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